



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Warren M. Farnworth

Serial No.: 10/663,944

Filed: September 16, 2003

For: STEREOLITHOGRAPHIC METHOD
FOR FORMING INSULATIVE COATINGS
FOR VIA HOLES IN SEMICONDUCTOR
DEVICES (as amended)

Confirmation No.: 3861

Examiner: W. Brewster

Group Art Unit: 2823

Attorney Docket No.: 2269-5700US
(02-1183.00/US)

Notice of Allowance Mailed:

July 13, 2005

NOTICE OF EXPRESS MAILING

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Person making Deposit: Steve Wong

AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

Amendments to the Specification begin on page 3 of this paper.

A Listing of the Claims begins on page 6 of this paper.

Amendments to the Drawings appear on page 10 of this paper and include both attached replacement sheets and annotated sheets showing changes.

Remarks begin on page 11 of this paper.

An **Appendix** including amended drawing figures is attached following page 11 of this paper.